

PATENT

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

APPLICANTS:	Jin-Hwa Heo	EXAMINER:	Maki A. Angadi
SERIAL NO.:	10/734,354	ART UNIT:	1792
FILED:	December 12, 2003	DOCKET:	8836-140 DIV (IE10178-US-1)
TITLE:	SEMICONDUCTOR DEVICE HAVING TRENCH ISOLATION LAYER AND A METHOD OF FORMING THE SAME		

Mail Stop Issue Fee  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 C.F.R. § 312**

Sirs:

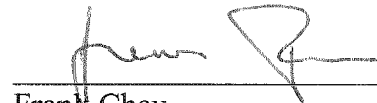
Applicants appreciate the Examiner's issuance of the Notice of Allowability and Supplemental Notice of Allowability.

The both Notices indicates that no foreign priority document under 35 U.S.C. § 119(a)-(d) or (f) had been received. Applicant respectfully disagrees with the Examiner's indication. The Korean Priority Application 2001-12603 filed 12 March 2001 was originally filed in the parent case U.S. Serial No. 09/990,740 filed on November 16, 2001, which since has issued as U.S. Patent No. 6,683,354 on January 27, 2004.

Applicant respectfully request an issuance of a Second Supplemental Notice of Allowability indicating that a certified copy of the above-mentioned priority document have been received in Application No. 09/990,740.

Respectfully submitted,

By:



Frank Chau  
Reg. No. 34,136  
Jaewoo Park  
Ltd. Rec. No. L0302  
Attorney for Applicant

F. CHAU & ASSOCIATE, LLC  
130 Woodbury Road  
Woodbury, New York 11797  
(516) 692-8888